FORM PTO-1449 (Rev. 2-32)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 100077	Serial No. TBD
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		Applicant: Heinz Busta	
		Filing Date: October 20, 2003	Group: TBD

U. S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
SJF		5,602,671	2/11/97	Hornbeck			
		5,694,740	12/9/97	Martin et al.			
		6,004,830	12/21/99	Potter			
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		6,100,477	8/8/00	Randall et al.			
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SJF		6,198,438	3/6/01	Herd et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initials	Document Number	Date	Country	Class	Sub class	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc).

EXAMINER		DATE CONSIDERED 1/31/06

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